

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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 Inventor Ross S. Dando et al.
 Assignee Micron Technology, Inc.
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Priority Examiner Karla A. Moore
 Attorney's Docket No. MI22-2432
 Customer No. 021567
 Title Chemical Vapor Deposition Apparatus

PRELIMINARY AMENDMENT

To: Mail Stop Patent Application
 Commissioner for Patents
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VIA EXPRESS MAIL

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Please enter the following amendments prior to examining the above-identified application.

AMENDMENTS